

| L Number | Hits | Search Text | DB | Time stamp |
|----------|------|---|---|------------------|
| 1 | 4789 | waveguide and cladd\$4 and etch\$4 | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2003/09/04 17:20 |
| 2 | 143 | (waveguide and cladd\$4 and etch\$4) and shadow\$4 | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2003/09/04 17:30 |
| 3 | 2 | ("6506289").PN. | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2003/09/04 17:30 |
| 4 | 22 | ("4437966" "5107538" "5119460" "5206925" "5252194" "5303319" "5381262" "5475528" "5483613" "5555127" "5563979" "5565071" "5603816" "5613995" "5719976" "5831262" "5841931" "5847865" "5855744" "5900057" "5966491" "6157765").PN. | USPAT | 2003/09/04 17:30 |
| 5 | 0 | 6506289.URPN. | USPAT | 2003/09/04 17:33 |
| - | 4789 | waveguide and cladd\$4 and etch\$4 | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2003/09/04 17:20 |
| - | 4099 | waveguide and cladding and etching | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2003/09/04 12:05 |
| - | 939 | (waveguide and cladd\$4 and etch\$4) and sputter\$4 | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2003/09/04 12:06 |
| - | 72 | ((waveguide and cladd\$4 and etch\$4) and sputter\$4) and planar adj substrate | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2003/09/04 12:06 |
| - | 1893 | ((65/386) or (385/129,132)).CCLS. | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2003/09/04 13:05 |
| - | 0 | ("6andcladd\$4").PN. | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2003/09/04 12:32 |
| - | 649 | ((65/386) or (385/129,132)).CCLS.) and cladd\$4 | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2003/09/04 12:32 |
| - | 12 | ((65/386) or (385/129,132)).CCLS. | USOCR | 2003/09/04 13:06 |
| - | 13 | (65/391,413,429,436).CCLS. | USOCR | 2003/09/04 13:07 |
| - | 551 | (65/391,413,429,436).CCLS. | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2003/09/04 13:07 |

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|---|-----|---|---|------------------|
| - | 194 | ((65/391,413,429,436).CCLS.) and cladd\$4 | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2003/09/04 13:08 |
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| 2 | 4099 | waveguide and cladding and etching | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2003/09/04 12:05 |
| 3 | 939 | (waveguide and cladd\$4 and etch\$4) and sputter\$4 | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2003/09/04 12:06 |
| 5 | 72 | ((waveguide and cladd\$4 and etch\$4) and sputter\$4) and planar adj substrate | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2003/09/04 12:06 |
| 6 | 1893 | ((65/386) or (385/129,132)).CCLS. | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2003/09/04 13:05 |
| 7 | 0 | ("6andcladd\$4").PN. | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2003/09/04 12:32 |
| 8 | 649 | ((65/386) or (385/129,132)).CCLS.) and cladd\$4 | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2003/09/04 12:32 |
| 9 | 12 | ((65/386) or (385/129,132)).CCLS. | USOCR | 2003/09/04 13:06 |
| 10 | 13 | (65/391,413,429,436).CCLS. | USOCR | 2003/09/04 13:07 |
| 11 | 551 | (65/391,413,429,436).CCLS. | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2003/09/04 13:07 |
| 12 | 194 | ((65/391,413,429,436).CCLS.) and cladd\$4 | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2003/09/04 13:08 |

**Inventor Name Search Result**

Your Search was:

Last Name = BAZYLENKO

First Name = MICHAEL

| Application# | Patent# | Status | Date Filed | Title | Inventor Name |
|--------------------------|-------------------------|--------|------------|--|--------------------|
| 60394927 | Not Issued | 159 | 07/11/2002 | METHOD OF FORMING A PLANAR WAVEGUIDE STRUCTURE | BAZYLENKO, MICHAEL |
| 60350409 | Not Issued | 159 | 10/19/2001 | BRAGG GRATING DEVICE | BAZYLENKO, MICHAEL |
| 60343292 | Not Issued | 159 | 10/19/2001 | PHOTONIC DEVICE | BAZYLENKO, MICHAEL |
| 60343291 | Not Issued | 159 | 10/19/2001 | DEVICE FOR COUPLING RADIATION INTO A WAVEGUIDE | BAZYLENKO, MICHAEL |
| 60343290 | Not Issued | 159 | 10/19/2001 | DEVICE FOR COUPLING RADIATION INTO A WAVEGUIDE | BAZYLENKO, MICHAEL |
| 60290374 | Not Issued | 159 | 05/11/2001 | SILICA-BASED OPTICAL DEVICE FABRICATION | BAZYLENKO, MICHAEL |
| 09986250 | Not Issued | 041 | 11/08/2001 | SILICA-BASED OPTICAL DEVICE FABRICATION | BAZYLENKO, MICHAEL |
| 09946712 | Not Issued | 030 | 09/04/2001 | PLANER WAVEGUIDE AND METHOD OF FORMATION | BAZYLENKO, MICHAEL |
| 09946394 | Not Issued | 161 | 09/04/2001 | WAVEGUIDE FORMATION | BAZYLENKO, MICHAEL |
| 09936775 | Not Issued | 071 | 11/16/2001 | WAVEGUIDE STRUCTURE AND METHOD OF FORMING THE WAVEGUIDE STRUCTURE | BAZYLENKO, MICHAEL |
| 09932238 | Not Issued | 030 | 08/17/2001 | METHOD OF DEPOSITING A CLADDING LAYER | BAZYLENKO, MICHAEL |
| 09931981 | Not Issued | 041 | 08/17/2001 | METHOD OF FORMING A PLANAR WAVEGUIDE CORE | BAZYLENKO, MICHAEL |
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| 09900630 | Not Issued | 041 | 07/06/2001 | PHOTONIC SIGNAL TRANSMITTING DEVICE | BAZYLENKO, MICHAEL |
| 09900612 | 6549688 | 150 | 07/06/2001 | MONOLITHICALLY-INTEGRATED | BAZYLENKO, MICHAEL |

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|--------------------------|-------------------------|-----|------------|---|------------------------|
| | | | | OPTICAL DEVICE AND METHOD OF FORMING SAME | |
| 09900438 | Not Issued | 094 | 07/06/2001 | PLANAR WAVEGUIDE AMPLIFIER | BAZYLENKO, MICHAEL |
| 09900418 | Not Issued | 061 | 07/06/2001 | PHOTONIC SIGNAL TRANSMITTING DEVICE | BAZYLENKO, MICHAEL |
| 09880517 | Not Issued | 041 | 06/12/2001 | ELECTRO-OPTIC WAVEGUIDE STRUCTURE | BAZYLENKO, MICHAEL |
| 09254532 | Not Issued | 161 | 06/01/1999 | REACTIVE ION ETCHING OF SILICA STRUCTURES | BAZYLENKO , MICHAEL |
| 09029407 | 6379873 | 150 | 12/22/1998 | METHOD AND APPARATUS FOR THE CONSTRUCTION OF PHOTSENSITIVE WAVEGUIDES | BAZYLENKO , MICHAEL V. |
| 08945041 | 6154582 | 150 | 02/12/1998 | FABRICATION METHOD OF MAKING SILICA-BASED OPTICAL DEVICES AND OPTO-ELECTRONIC | BAZYLENKO , MICHAEL V. |

Inventor Search Completed: No Records to Display.

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|---------------------------------|--|--------------------------------------|---------------|
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| | <input type="text" value="bazylenko"/> | <input type="text" value="michael"/> | |

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